



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
[www.uspto.gov](http://www.uspto.gov)



Bio Data Sheet

CONFIRMATION NO. 2644

SERIAL NUMBER 10/735,621	FILING DATE 12/16/2003 ✓ RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 829-619
-----------------------------	--	--------------	------------------------	--------------------------------

## APPLICANTS

Akira Shimizu, Nara, JAPAN;

*MTC*Yuhsuke Fukuoka, Nara, JAPAN;  
Yasushi Fujioka, Kyoto, JAPAN; Katsushi Kishimoto, Kyoto, JAPAN;  
Katsuhiro Nomoto, Osaka, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

*NONE MTC*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-367402 12/18/2002

*MTC*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/24/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	Met after Allowance <i>MTC</i>	10	26	6
Verified and Acknowledged	<i>Maurice Thrailkill</i> Examiner's Signature	Initials			

## ADDRESS

23117  
NIXON & VANDERHYE, PC  
901 NORTH GLEBE ROAD, 11TH FLOOR  
ARLINGTON, VA  
22203

## TITLE

Plasma CVD apparatus, and method for forming film and method for forming semiconductor device using the same

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
------------	---	---